Effect of Mn doping on ultrafast carrier dynamics in thin films of the topological insulator Bi₂Se₃

Yuri D. Glinka,^{1,2}* Sercan Babakiray,¹ Mikel B. Holcomb,¹ and David Lederman¹

¹Department of Physics and Astronomy, West Virginia University, Morgantown, WV 26506-6315, USA

²Institute of Physics, National Academy of Sciences of Ukraine, Kiev 03028, Ukraine

Transient reflectivity (TR) measured at laser photon energy 1.51 eV from the indirectly intersurface coupled topological insulator $\text{Bi}_{2,x}\text{Mn}_x\text{Se}_3$ films (12 nm thick) revealed a strong dependence of the rise-time and initial decay-time constants on photoexcited carrier density and Mn content. In undoped samples (x = 0), these time constants are exclusively governed by electron-electron and electron-phonon scattering, respectively, whereas in films with x = 0.013 - 0.27 ultrafast carrier dynamics are completely controlled by photoexcited electron trapping by ionized Mn²⁺ acceptors and their dimers. The shortest decay-time (~0.75 ps) measured for the film with x = 0.27 suggests a great potential of Mn-doped Bi₂Se₃ films for applications in high-speed optoelectronic devices. Using Raman spectroscopy exploiting similar laser photon energy (1.58 eV), we demonstrate that due to indirect intersurface coupling in the films, the photoexcited electron trapping in the bulk enhances the electron-phonon interaction strength in Dirac surface states.

1. Introduction

Ultrafast carrier dynamics in the topological insulator (TI) [1,2] Bi_2Se_3 is of great interest to scientific and technological communities due to potential applications of these materials in novel high-speed electronics. Owing to the unique nature of these three-dimensional (3D) materials that are insulating in the bulk (bandgap of $Bi_2Se_3 \sim 0.3 \text{ eV}$) [3], but conducting at the surface due to two-dimensional (2D) Dirac surface states (SS), TIs offer an opportunity to design tunable electronic high-speed devices because of the different mechanisms of electron energy relaxation in 3D and 2D states associated with the electron-phonon (Fröhlich) interaction and deformation-potential/thermoelastic-scattering, respectively [4, 5].

Ultrafast carrier dynamics in TIs have been studied using timeand angle-resolved photoemission spectroscopy (TrARPES) [6-11], transient reflectivity (TR) at photon energy ~1.5 eV [4, 12-16], and ultrafast optical-pump terahertz-probe spectroscopy (probe photon energy ~1.0 meV) [17]. In the latter case, the ultrafast low-energy dynamics of free carriers residing in Dirac SS are found to take a few tens of ps, thus being much longer than the characteristic decaytime in graphene (1-2 ps) [18, 19]. Alternatively, the ultrafast carrier relaxation dynamics probed at photon energy ~1.5 eV includes fast electron-electron thermalization (~0.3-0.5 ps) and longitudinal-optical(LO)-phonon relaxation in the bulk (~1.5-3.5 ps) that leads to a metastable population of the conduction band edge [4, 12-16], which continuously feeds a nonequilibrium population of Dirac SS (~5-220 ps) [4,6,15] being likely mediated by the coherent acoustic phonon dynamics [20]. Afterwards the quasi-equilibrium carrier population in Dirac SS is reached within extremely long times of ≥ 10 ns [4, 8, 15, 20, 21]. In addition, recombination of carriers residing in the lower and higher energy Dirac cones [11] can strongly affect the carrier relaxation dynamics [15], giving rise to the broadband visible-range photoluminescence recently observed [22]. The ultrafast carrier dynamics can, in principle, also be affected by electron trapping when TIs are additionally doped with impurities. It would be of great interest, in this regard, to magnetic impurities (such as Mn) which can break down the time-reversal symmetry in Dirac SS and hence strongly affect the electron dynamics in TIs.

In this paper, we report on a TR study of ultrafast carrier relaxation dynamics probed at photon energy ~1.51 eV in the indirectly intersurface-coupled TI Bi2-xMnxSe3 films (12 nm thick). We show that Mn doping significantly alters the risetime and initial decay-time constants of the TR signals, which in undoped samples are associated with electron-electron and electron-LO-phonon scattering, respectively [4, 12-16]. Consequently, ultrafast carrier relaxation in Mn-doped Bi₂Se₃ films is found to be governed by the electron trapping kinetics involving ionized Mn²⁺acceptors and their dimers. The shortest decay-time of ~0.75 ps observed for the film with x =0.27 is similar to that of the characteristic value of massive Dirac fermion relaxation in bilayer graphene measured using TrARPES and exploiting optical pumping at similar photon energy (1.55 eV) [23], thus suggesting that Mn-doped Bi₂Se₃ thin films have a great potential for applications in high-speed optoelectronic devices.

2. Samples and experimental setup

Experiments were performed on 12 nm thick $Bi_{2,x}Mn_xSe_3$ epitaxial films with x = 0, 0.013, 0.026, 0.078, 0.131, 0.182, and 0.27. The films were grown on a 0.5 mm thick $Al_2O_3(0001)$ substrate by molecular beam epitaxy, with a 10 nm thick MgF₂ capping layer to protect against oxidation. The growth and Mn-doping processes were similar to that described previously [5, 24, 25]. The films were found to be naturally *n*-doped with an average free-electron density $n_e \sim$ 2.54 \times 10¹⁹ cm⁻³, determined from Hall conductivity measurements at 2 K, which is typical for as-grown Bi₂Se₃ [26].

TR measurements were performed at room temperature in air using a Ti:Sapphire laser with a pulse duration of ~100 fs, a center photon energy of 1.51 eV (820 nm) and a repetition rate of 80 MHz. A wide range of laser powers ($0.03-1.76 \times 10^9$ W/cm²) was employed, where the pump was at normal incidence and the probe was at an incident angle of ~ 15° , focused through the same lens to a spot diameter of ~100 µm.

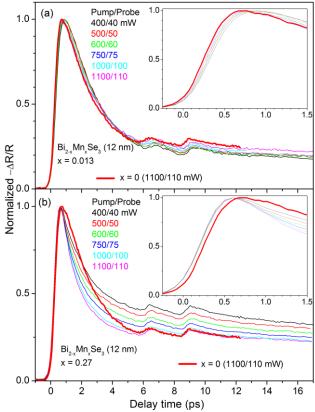


FIG. 1. Normalized TR traces for 12 nm thick $\text{Bi}_{2-x}\text{Mn}_x\text{Se}_3$ films with x = 0.013 (a) and x = 0.27 (b) measured with 0.05 ps steps and with various pump-probe average powers as indicated by the corresponding colors. Wider red curves correspond to the undoped sample (x = 0). Insets zoom in on the short delay-time part of the same TR traces.

The pump and probe beams were cross-polarized. No film damage was observed for the laser powers used in the measurements reported here. Raman measurements were performed also at room temperature in air using a Renishaw inVia Raman Spectrometer equipped with the 785 nm (photon energy 1.58 eV) solid-state laser of 30 mW output power [5, 26].

3. Experimental results and discussion

Figure 1 shows the typical TR traces measured with various pump-probe average powers for Bi_{2-x}Mn_xSe₃ films with x = 0.013 and 0.27. The TR traces clearly demonstrate that the ultrafast carrier relaxation dynamics strongly depend on photoexcited carrier density and Mn content. Similar measurements were performed for undoped (x = 0) and other Mn-doped samples used in this study. We note that there are two weak stepwise features with onsets at ~5.9 and ~8.4 ps, which are due to the reflection of pump and probe beams from the internal surface of the sapphire substrate of thickness $d_{Sa} = 0.5$ mm, respectively. The amount of light transmitted through the sample is estimated as ~20 %. Due to the normal incidence of the pump, the first onset delay-time (τ_{onset}) can be precisely obtained by taking into account the double-pass of incident pump light in the sapphire substrate of refractive index n_r ~

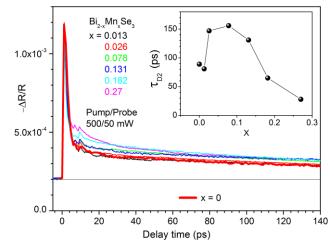


FIG. 2. TR traces for 12 nm thick $Bi_{2,x}Mn_xSe_3$ films measured with 1 ps steps and with various Mn content (*x*) as indicated by the corresponding colors. The wider red curve represents the TR trace of the undoped film (*x* = 0). Inset shows the Mn content dependence of τ_{D2} constant.

1.76, thus yielding $\tau_{onset} = 2d_{Sa}n_r/c = 5.9$ ps, where *c* is the speed of light in vacuum.

Figure 2 shows the longer delay-time TR traces that are negative in accordance with their absorption bleaching nature and are characterized by a rise and multiple decay behavior [4, 12-16]. The corresponding rise-time (τ_R) and decay-time (τ_{Di}) constants were estimated using a multiexponential fitting function [27],

$$-\Delta R/R = H(1 - e^{-t/\tau_R})(a_1 e^{-t/\tau_{D1}} + a_2 e^{-t/\tau_{D2}} + a_3 e^{-t/\tau_{D3}}), \quad (1)$$

where H is the Heaviside step function that accounts for the pump-probe cross-correlation time and a_i are the partial amplitudes. For the undoped samples, τ_R is associated with electron-electron thermalization, whereas τ_{D1} , τ_{D2} , and τ_{D3} describe the intraband electron-LO-phonon relaxation in the bulk, the bulk interband electron-LO-phonon relaxation that feeds a population of Dirac SS, and a final localization of electrons in Dirac SS, respectively [4, 6, 8, 15, 16, 20, 21]. The doping of the films with Mn does not affect appreciably τ_{D3} , whereas τ_{D2} reveals a non-monotonic behavior (figure 2, inset). Taking into account the bulk carrier depletion effect occurring with decreasing Bi₂Se₃ film thickness as a consequence of indirect intersurface coupling [15, 16], one can assume that an increase of τ_{D2} with increasing Mn content is due to the suppression of the interband electron-LO-phonon relaxation channel when the photoexcited electron density (n)in the bulk is reduced, being most likely due to trapping. Once Mn content exceeds $x \approx 0.1$, the opposite behavior emerges, indicating an increase of the bulk electron density. We note that because $n > n_e$ [4, 26], the effect of free-electron density on the photoexcited electron relaxation dynamics seems insignificant.

Similar non-monotonic behavior also appears for τ_R and τ_{D1} . Figure 3 compares the variations of τ_R and τ_{D1} with increasing *n* for undoped and Mn-doped Bi₂Se₃ films. In undoped films, τ_{D1} is associated with electron-LO-phonon

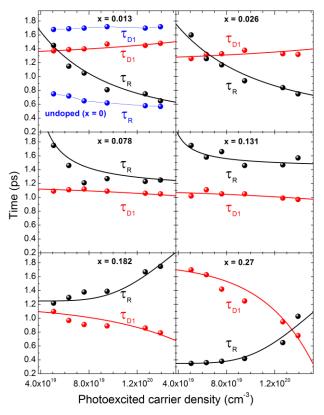


FIG. 3. The photoexcited carrier density dependences of τ_R and τ_{D1} for 12 nm thick Bi_{2-x}Mn_xSe₃ films with *x* as indicated. The black and red color curves show the corresponding fits to the data using equations (8) and (10). All the fitting parameters are the same including $\tau_{e-LO} = 1.68$ ps, except for *A*, σ_1 , and σ_2 .

interactions ($\tau_{e-LO} = 1.68$ ps), which remains unchanged with the pump power (with *n*), thus reflecting the fact that the rate of polar Fröhlich electron-LO-phonon interaction ($1/\tau_{e-LO}$) is independent of the carrier density [4]. One exception can occur for a degenerate electron gas in heavily doped semiconductors due to the energy band nonparabolicity, which mainly appears in low-temperature measurements [28]. In contrast, τ_R in undoped samples is associated with electronelectron interactions and hence slightly decreases with increasing *n* (figure 3) since the electron-electron scattering rate ($1/\tau_R$) varies with carrier density as $n^{2/3}$ and as *n* in 3D and 2D structures, respectively [29].

The τ_R and τ_{D1} trends with increasing *n* and Mn content show a completely different behavior in Mn-doped Bi₂Se₃ films (figures 3 and 4) and therefore should be associated with electron trapping kinetics in a similar manner to those occurring in low-temperature grown GaAs, where the much shorter ultrafast carrier dynamics compared to hightemperature grown GaAs are mainly governed by the trapping of electrons by As cluster point defects [30]. Specifically, τ_R , and τ_{D1} become comparable, giving rise to a quite symmetric shape of TR traces in the short delay-time range when the highest laser power is applied to the Bi_{2-x}Mn_xSe₃ film with x =0.27 [figures 1(b) and 4(b)]. The corresponding shortest τ_{D1} ~0.75 ps is comparable to the characteristic value of massive

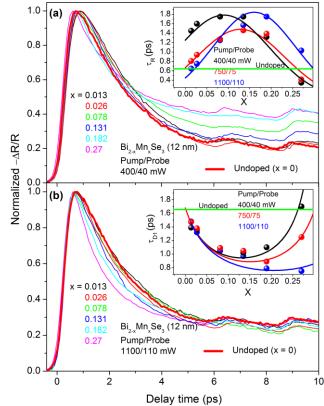


FIG. 4. Normalized TR traces measured with 0.1 ps steps and with 400/40 mW (a) and 1100/110 mW (b) pump-probe powers for 12 nm thick Bi_{2-x}Mn_xSe₃ films with x as indicated by the corresponding colors. Insets show the Mn content dependences of τ_R and τ_{D1} for TR traces measured with three different pump/probe powers as indicated. The green horizontal lines indicate τ_R and τ_{D1} for the undoped film (x = 0). The corresponding color curves show the fits to the data using equations (8) and (10). All the fitting parameters are the same including $\tau_{e-LO} = 1.68$ ps, except for A, σ_1 , and σ_2 .

Dirac fermion relaxation in bilayer graphene (0.65 ps) measured using TrARPES with optical pumping at similar photon energy (1.55 eV) [23], thus suggesting a new highly promising material for electronic and optoelectronic applications. In addition, the slopes of τ_R and τ_{D1} with increasing *n* change sign when Mn content exceeds $x \approx 0.1$ (figure 3). Moreover, τ_R and τ_{D1} at fixed *n* depend on *x* also non-monotonically, revealing opposite trends with a minimum in τ_{D1} coinciding with a maximum in τ_R , both shifting towards higher Mn content with increasing *n* (figure 4, insets). This correlation between τ_R and τ_{D1} seems unique due to the joint dependence of the electron trapping and electron-electron scattering rates on the density of photoexcited electrons [29, 31].

The nature of traps is associated with the substitution of Mn atoms into Bi^{3+} sites with 2+ valence [25, 31]. As shown in figure 5, Mn content dependences of Raman peak intensity, shift, and linewidth are monotonic for the entire range of Mn doping used, thus confirming that the substitution of Mn atoms in Bi_2Se_3 films dominates over possible intercalation

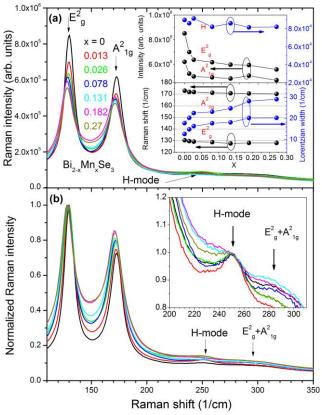


FIG. 5. (a) Raman spectra measured for 12 nm thick $\text{Bi}_{2,x}\text{Mn}_x\text{Se}_3$ films with *x* as indicated by the corresponding colors. (b) The same spectra but normalized at the peak position of the bulk E_g^2 mode (~130 cm⁻¹). Inset in (a) shows the Mn content dependences of the phonon mode intensity, shift, and Lorentzian linewidth. Inset in (b) shows the same spectra but normalized at the peak position of the surface H-mode (~252 cm⁻¹).

between the quintuple layers [25, 32]. The red-shift of the bulk phonon modes $(E_{g}^{2} and A_{1g}^{2})$ with increasing Mn content is due to phonon softening resulting from a weakening of interlayer van-der-Waals forces due to Bi substitution by the smaller ionic radius Mn atom [33, 34]. For the same reason, the bulk phonon modes significantly broaden [figure 5(a)], as it typically occurs in strain-induced or disordered systems [35, 36]. The broadening of the surface H-mode associating with the continuous hexagonally arranged Se atom network of Dirac SS [37] is asymmetric due to the Fano resonance [5, 26], which is maximized for films with $x \approx 0.13$ [figure 5(b), inset]. This behavior in general follows the non-monotonic dependence of the rise-time and initial decay-time constants with increasing Mn content (figures 2 and 4, insets), indicating that electron trapping in the bulk enhances the electronphonon interaction strength in Dirac SS, similarly as with decreasing film thickness [5, 26]. It should be noted that the latter effect can also be associated with the time-reversal symmetry breaking induced by Mn impurities residing in close proximity to the film surface. The resulting elimination of the topological edge states will turn the system into a trivial insulator, where electron-phonon coupling is expected to be stronger due to the Fröhlich-type interaction.

Because Mn²⁺ replaces a Bi³⁺ ion, the substituted Mn atom provides one fewer electron or, equivalently, donates a hole, thus acting as an acceptor and showing a hole doping effect [38]. However, because the average vertical ionization energy of Mn^{2+} (~1.6 eV) is comparable to the laser photon energy used in our experiments ($\hbar \omega_t = 1.51$ eV) [39], all Mn²⁺ acceptors are expected to be ionized to the Mn^{3+} state $(Mn^{2+} \xrightarrow{\hbar\omega_L} Mn^{3+} + e)$. Therefore, we consider Mn^{3+} as electron traps in the photoexcited Mn-doped Bi₂Se₃ films, which after electron capture transform to Mn^{2+} acceptor sites. This behavior is consistent with the generally accepted tendency regarding the compensation of donors in this family of materials by impurities with one fewer electron than Bi [40]. Furthermore, a weak coupling between two neighboring substituted Mn^{2+} acceptors is expected to occur with increasing Mn content [41]. Two electron trapping by Mn³⁺-Mn³⁺ dimers immediately transform them to the strongest exchange interaction state of Mn²⁺-Mn³⁺ [42], donating one extra electron. Consequently, Mn dimerization reduces the electron trapping efficiency. We note that the substitutionaltype aggregation of Mn²⁺ acceptors should be distinguished from the Cu intercalation-type aggregation in the van der Waals gaps between the neighboring quintuple layers of Cudoped Bi₂Se₃, where Cu atoms behave as donors [43].

The resulting evolution of the electron density is governed by the first-order trapping kinetics [44],

$$dn/dt = -\upsilon \sigma_1 n(n_t - n_t^*) + \upsilon \sigma_2 n(n_d - n_d^*), \qquad (2)$$

where *n* and n_t^* are the densities of photoexcited electrons and electrons trapped by ionized Mn²⁺ acceptors of density n_t ; while n_d and n_d^* denote the densities of dimers and the corresponding trapped electrons; v is the electron thermal velocity and σ_1 and σ_2 are the trapping cross sections of the Mn monomers and dimers. The dimer density is expected to grow quadratically with n_t [45, 46], so that

$$n_d = K n_t^2 , \qquad (3)$$

where *K* is a ratio of rate constants for dimers and monomers at a monomer-dimer self-associating equilibrium. Consequently, the ratio *K* characterizes the efficiency of dimerization and has a dimension of cm^3 . The solution of equation (2) is

$$n = n_0 e^{-t/\tau_t} , \qquad (4)$$

where n_0 is the initial density of photoexcited electrons that are subjected to trapping with a trapping rate

$$\tau_t^{-1} = \upsilon \sigma_1 (n_t - n_t^*) - \upsilon \sigma_2 (n_d - n_d^*).$$
 (5)

The density of photoexcited electrons trapped by ionized Mn^{2+} acceptors and their dimers can be obtained using the first-order trapping equation [47],

$$dn_{t}^{*}/dn = \sigma_{1}\delta_{p}(n_{t}-n_{t}^{*}); \quad dn_{d}^{*}/dn = \sigma_{2}\delta_{p}(n_{d}-n_{d}^{*}), \quad (6)$$

where δ_p is the characteristic interaction length (light penetration depth ~12 nm) [4]. The solution of equation (6) is

$$n_t^* = n_t (1 - e^{-\sigma_1 \delta_p n_0}) ; \quad n_d^* = n_d (1 - e^{-\sigma_2 \delta_p n_0}) .$$
(7)

Using equations (5) and (7) and taking into account that $\tau_{D1}^{-1} = \tau_{e-LO}^{-1} + \tau_t^{-1}$, τ_{D1} can be expressed as

4

$$\tau_{D1} = \tau_{e-LO} \Big[1 + \tau_{e-LO} (\upsilon \sigma_1 n_t e^{-\sigma_1 \delta_p n_0} - \upsilon \sigma_2 K n_t^2 e^{-\sigma_2 \delta_p n_0}) \Big]^{-1}.$$
(8)

The slope of τ_{D1} with respect to both n_0 at fixed n_t and n_t at fixed n_0 changes sign when Mn dimers dominate the trapping kinetics. In the absence of dimerization (K = 0), τ_{D1} increases with increasing n_0 at fixed n_t and decreases with increasing n_t at fixed n_0 , thus showing the common monomer-type electron trapping dynamics (figures 3 and 4).

Using equation (4), the electron-electron scattering rate for the 3D structure case [29] can be treated at fixed time t_f as

$$\tau_R^{-1} = (1/A) n^{2/3} = (1/A) (n_0 e^{-t_f/\tau_t})^{2/3},$$
(9)

where *A* is a proportionality coefficient. Accordingly, $(\tau_R)^{-1}$ is completely governed by electron trapping and Mn dimerization since both processes affect the electron density. Using equations (5), (7), and (9), the expression for τ_R finally reads as

$$\tau_{R} = A \left[n_{0} e^{-\tau_{f} \upsilon(\sigma_{1} n_{e} e^{-\sigma_{1} \delta_{p} n_{0}} - \sigma_{2} K n_{i}^{2} e^{-\sigma_{2} \delta_{p} n_{0}})} \right]^{-2/3}.$$
 (10)

We note that τ_R changes the slope with respect to both n_0 at fixed n_t and n_t at fixed n_0 at the same conditions mentioned for τ_{D1} , whereas the overall trend is opposite to that of τ_{D1} . The fits of the experimental data shown in figures 3 and 4 using equations (8) and (10) reproduce all the variations of τ_{D1} and τ_R with n_0 and n_t , thus proving the validity of the model. We note that if the electron-electron scattering rate in Eq. (9) switches to the 2D structure case $(\tau_R^{-1} \sim n)$ [29], the experimental data can also be fitted quite well, thus indicating that Mn doping effect on electron-electron thermalization dynamics is not sensitive enough to distinguish between 2D and 3D states in TIs. The Mn dimer cross section (σ_2) obtained from the fits is only ~3 times greater than that for Mn monomers ($\sigma_1 = \pi R^2 \sim 0.03 \text{ nm}^2$, where $R \sim 0.1 \text{ nm}$ is the Mn ionic radius), confirming that only one ionized Mn²⁺ acceptor of the dimer traps the electron. Because $\sigma_2 > \sigma_1$, the Mn content extrema should shift toward the higher values with increasing n_0 due to the faster decrease of the negative term in the parentheses of equations (8) and (10), thus being in agreement with experimental observations shown in insets of figure 4.

4. Conclusion

In summary, we have demonstrated that Mn doping of 12 nm thick Bi_2Se_3 films strongly affects the rise-time and initial decay-time constants of photoexcited electron relaxation, which in undoped samples are exclusively governed by the electron-electron and electron-LO-phonon scattering, respectively. The effect is completely controlled by the kinetics of photoexcited electron trapping by ionized Mn^{2+} acceptors and their dimers. The observed shortest decay-time of ~0.75 ps is comparable to the characteristic value of massive Dirac fermion relaxation in bilayer graphene, suggesting a great potential of Mn-doped Bi_2Se_3 films for applications in high-speed optoelectronic devices.

Acknowledgments

We thank T. A. Johnson for helping with the growth of the MgF_2 capping layer in some of the original samples. This work was supported by a Research Challenge Grant from the West Virginia Higher Education Policy Commission (HEPC.dsr.12.29). Some of the work was performed using the West Virginia University Shared Research Facilities.

References

- [1] Murakami S 2007 New J. Phys. 9 356
- [2] Hasan M Z and Kane C L 2010 Rev. Mod. Phys. 82 3045
- [3] Cho S, Butch N P, Paglione J and Fuhrer M S 2011 Nano Lett. 11 1925
- [4] Glinka Y D, Babakiray S, Johnson T A, Bristow A D, Holcomb M B and Lederman D 2013 Appl. Phys. Lett. 103 151903
- [5] Glinka Y D, Babakiray S and Lederman D 2015 J. Appl. Phys. 118 135713
- [6] Sobota J A, Yang S, Analytis J G, Chen Y L, Fisher I R, Kirchmann P S and Shen Z-X 2012 Phys. Rev. Lett. 108 117403
- [7] Wang Y H, Hsieh D, Sie E J, Steinberg H, Gardner D R, Lee Y S, Jarillo-Herrero P and Gedik N 2012 Phys. Rev. Lett. 109 127401
- [8] Crepaldi A, Cilento F, Ressel B, Cacho C, Johannsen J C, Zacchigna M, Berger H, Bugnon P, Grazioli C, Turcu I C E, Springate E, Kern K, Grioni M and Parmigiani F 2013 *Phys. Rev. B* 88 121404
- [9] Hajlaoui Y M, Papalazarou E, Mauchain J, Perfetti L, Taleb-Ibrahimi A, Navarin F, Monteverde M, Auban-Senzier P, Pasquier C R, Moisan N, Boschetto D, Neupane M, Hasan M Z, Durakiewicz T, Jiang Z, Xu Y, Miotkowski I, Chen Y P, Jia S, Ji H W, Cava R J and Marsi M 2014 *Nature Comm.* **5** 3003
- [10] Wang Y H, Steinberg H, Jarillo-Herrero P and Gedik N 2013 Science 342 453
- [11] Sobota J A, Yang S-L, Kemper A F, Lee J J, Schmitt F T, Li W, Moore R G, Analytis J G, Fisher I R, Kirchmann P S, Devereaux T P and Shen Z-X 2013 Phys. Rev. Lett. 111 136802
- [12] Qi J, Chen X, Yu W, Cadden-Zimansky P, Smirnov D, Tolk N H, Miotkowski I, Cao H, Chen Y P, Wu Y, Qiao S and Jiang Z 2010 Appl. Phys. Lett. 97 182102
- [13] Kumar N, Ruzicka B A, Butch N P, Syers P, Kirshenbaum K, Paglione J and Zhao H 2011 Phys. Rev. B 83 235306
- [14] Lai Y-P, Chen H-J, Wu K-H and Liu J-M 2014 Appl. Phys. Lett. 105 232110
- [15] Glinka Y D, Babakiray S, Johnson T A, Holcomb M B and Lederman D 2014 Appl. Phys. Lett. 105 171905
- [16] Kim S, Shin D H, Kim J H, Jang C W, Park J W, Lee H, Choi S-H, Kim S H, Yee K-J, Bansal N and Oh S 2016 Nanotech. 27 045705
- [17] Sim S, Brahlek M, Koirala N, Cha S, Oh S and Choi H 2014 *Phys. Rev. B* 89 165137
- [18] Johannsen J C, Ulstrup S, Cilento F, Crepaldi A, Zacchigna M, Cacho C, Edmond Turcu I C, Springate E, Fromm F, Raidel C, Seyller T, Parmigiani F, Grioni M and Hofmann P 2013 *Phys. Rev. Lett.* **111** 027403
- [19] Gierz I, Petersen J C, Mitrano M, Cacho C, Turcu I C E, Springate E, Stohr A, Kohler A, Starke U and Cavalleri A 2013 *Nat. Mater.* 12 1119
- [20] Glinka Y D, Babakiray S, Johnson T A, Holcomb M B and Lederman D 2015 J. Appl. Phys. 117 165703
- [21] Neupane M, Xu S-Y, Ishida Y, Jia S, Fregoso B M, Liu C, Belopolski I, Bian G, Alidoust N, Durakiewicz T, Galitski V,

Shin S, Cava R J and Hasan M Z 2015 Phys. Rev. Lett. 115 116801

- [22] Vargas A, Liu F and Kar S Appl. Phys. Lett. 106 243107
- [23] Ulstrup S, Johannsen J C, Cilento F, Miwa J A, Crepaldi A, Zacchigna M, Cacho C, Chapman R, Springate E, Mammadov S, Fromm F, Raidel C, Seyller T, Parmigiani F, Grioni M, King P D C and Hofmann P 2014 *Phys. Rev. Lett.* **112** 257401
- [24] Tabor P, Keenan C, Urazhdin S and Lederman D 2011 Appl. Phys. Lett. 99 013111
- [25] Babakiray S, Johnson T A, Borisov P, Holcomb M B, Lederman D, Marcus M A and Tarafder K 2015 J. Appl. Phys. 118 045302
- [26] Glinka Y D, Babakiray S, Johnson T A and Lederman D 2015 J. Phys.: Condens. Matter 27 052203
- [27] Glinka Y D, Tolk N H, Liu X, Sasaki Y and Furdyna J K 2008 J. Appl. Phys. 103 043708
- [28] Poujade A M and Albany H J 1969 Phys. Rev. 182 802
- [29] Snoke D W 1994 Phys. Rev. B 50 11583
- [30] Glinka Y D, Maryenko D and Smet J H 2008 *Phys. Rev. B* 78 035328
- [31] Li S S 2006 Semiconductor Physical Electronics (New York: Springer)
- [32] Zhang J-M, Ming W, Huang Z, Liu G-B, Kou X, Fan Y, Wang K L and Yao Y 2013 Phys. Rev. B 88 235131
- [33] Zhang J, Peng Z, Soni A, Zhao Y, Xiong Y, Peng B, Wang J, Dresselhaus M S and Xiong Q 2011 Nano Lett. 11 2407
- [34] Yang X X, Zhou Z F, Wang Y, Jiang R, Zheng W T and Sun C Q 2012 J. Appl. Phys. 112 083508
- [35] Bartolo K M F, Hossain M Z, Teweldebrhan D and Balandin A A 2010 Appl. Phys. Lett. 96 153103

- [36] Shivaraman S, Barton R A, Yu X, Alden J, Herman L, Chandrashekhar M V S, Park J, McEuen P L, Parpia J M, Craighead H G and Spencer M G 2009 *Nano Lett.* 9 3100
- [37] Glinka Y D, Babakiray S, Johnson T A, Holcomb M B and Lederman D 2015 Phys. Rev. B 91 195307
- [38] Chen Y L, Chu J-H, Analytis J G, Liu Z K, Igarashi K, Kuo H-H, Qi X L, Mo S K, Moore R G, Lu D H, Hashimoto M, Sasagawa T, Zhang S C, Fisher I R, Hussain Z and Shen Z X 2010 Science **329** 659
- [39] Moens J, Seidel R, Geerlings P, Faubel M, Winter B and Blumberger J 2010 J. Phys. Chem. B 114 9173
- [40] Hor Y S, Richardella A, Roushan P, Xia Y, Checkelsky J G, Yazdani A, Hasan M Z, Ong N P and Cava R J 2009 *Phys. Rev.* B 79 195208
- [41] Vink A P, De Bruin M A, Roke S, Peijzel P S and Meijerink A 2001 J. Electrochem. Soc. 148, E313
- [42] Streltsov S V, Pchelkina Z V, Khomskii D I, Skorikov N A, Anokhin A O, Shvachko Y N, Korotin M A, Anisimov V I and Ustinov V V 2014 *Phys. Rev. B* 89 014427
- [43] Wang Y-L, Xu Y, Jiang Y-P, Liu J-W, Chang C-Z, Chen M, Li Z, Song C-L, Wang L-L, He K, Chen X, Duan W-H, Xue Q-K and Ma X-C 2011 Phys. Rev. B 84 075335
- [44] Williams R T, Klein P H, Marquardt C L 1978 In Proc. Conf. on Laser Induced Damage in Optical Materials 1977, ed. by A.J. Glass, A.H. Guenther, US Nat'l Bur. Stand. Spec. Publ. No.509 (Washington, DC: US GPO) p.481
- [45] Munoz A F, Cabrera E B, Riveros H R, Patron M and Rubio J O 1985 Phys. Rev. B 31 8196
- [46] Wessels B W 2008 New J. Phys. 10 055008
- [47] Afanas'ev V V 2008 Internal Photoemission Spectroscopy: Principles and Applications (Oxford: Elsevier)